

PI nano® Z Microscope Scanner for Microtiter Plates

Large Clear Aperture, Low Profile, with Digital Controller



P-736

- Fast step & settle
- Clear aperture for well plates and low profile for easy integration
- Travel range 220 µm
- Outstanding lifetime due to PICMA® piezo actuators
- Piezoresistive sensors for lower cost
- Capacitive sensors for higher stability

Precision-class nanopositioning system for high-resolution microscopy

Optimized for very fast step-and-settle. Exceptionally low profile of 18 mm for easy integration. Versions available for inverted microscopes from Nikon and Olympus.

PICMA® piezo actuator drive

All-ceramic insulation for maximum operating time. Significantly higher humidity resistance. Excellent guiding accuracy due to FEA-modeled flexure joints.

Choice of feedback sensors: piezoresistive or capacitive

- High-resolution piezoresistive sensors ensure stable position control
- Direct-measuring capacitive sensors for considerably improved stability and repeatability compared to piezoresistive sensors

System with controller and software

The compact E-709 digital servo piezo controller is included in the delivery. Digital servos allow adaptation of all control parameters on the fly, by software. Control is possible via USB, RS-232 and a broadband analog interface. Supports PIMikroMove, NanoCapture. PI General Command Set (GCS). Drivers for NI LabVIEW, shared libraries for Windows and Linux. Compatible with µManager, MATLAB and Andor iQ.

Application fields

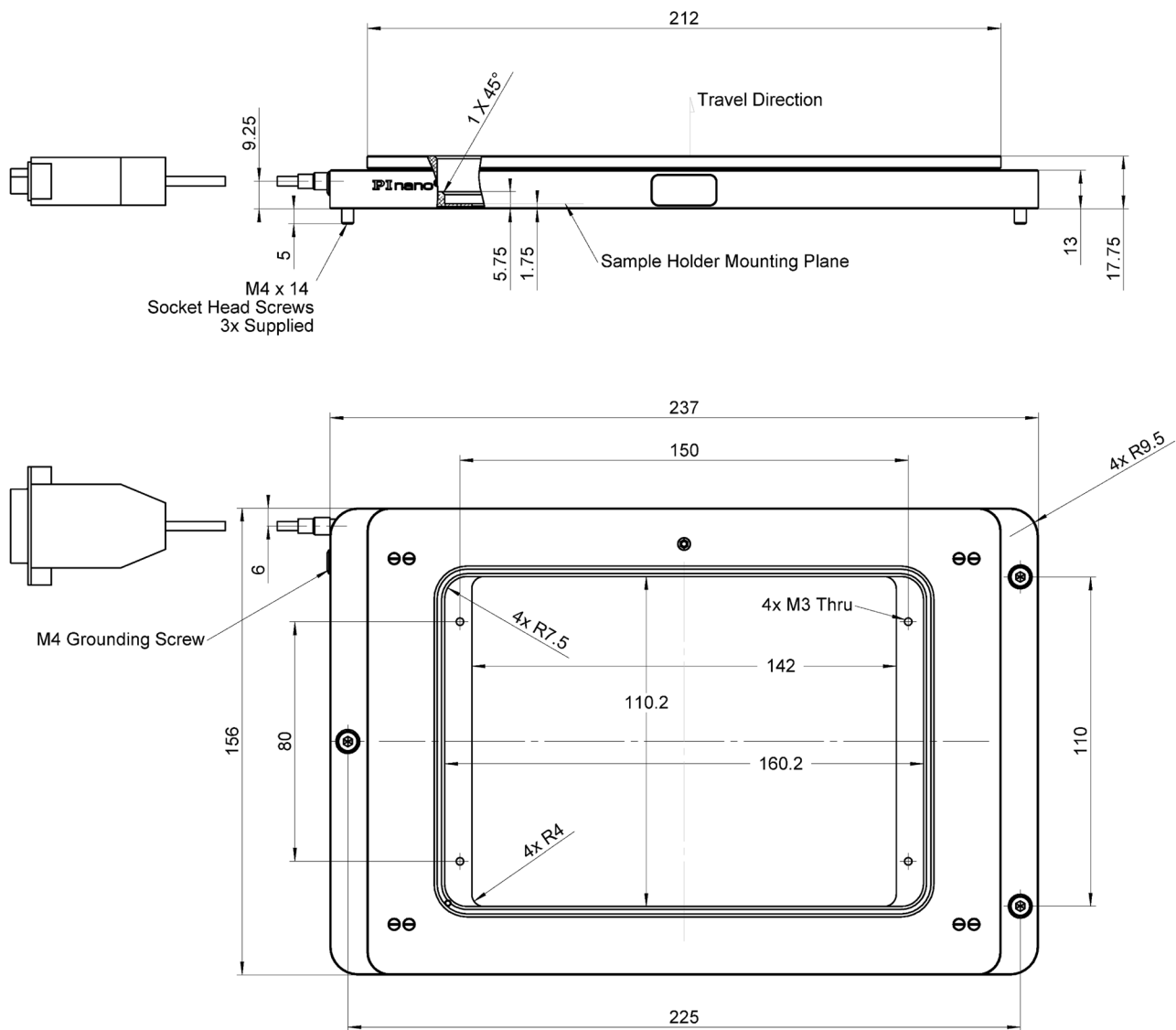
Confocal microscopy, 3D imaging, laser technology, interferometry, metrology / measuring technology, biotechnology, micromanipulation.

Specifications

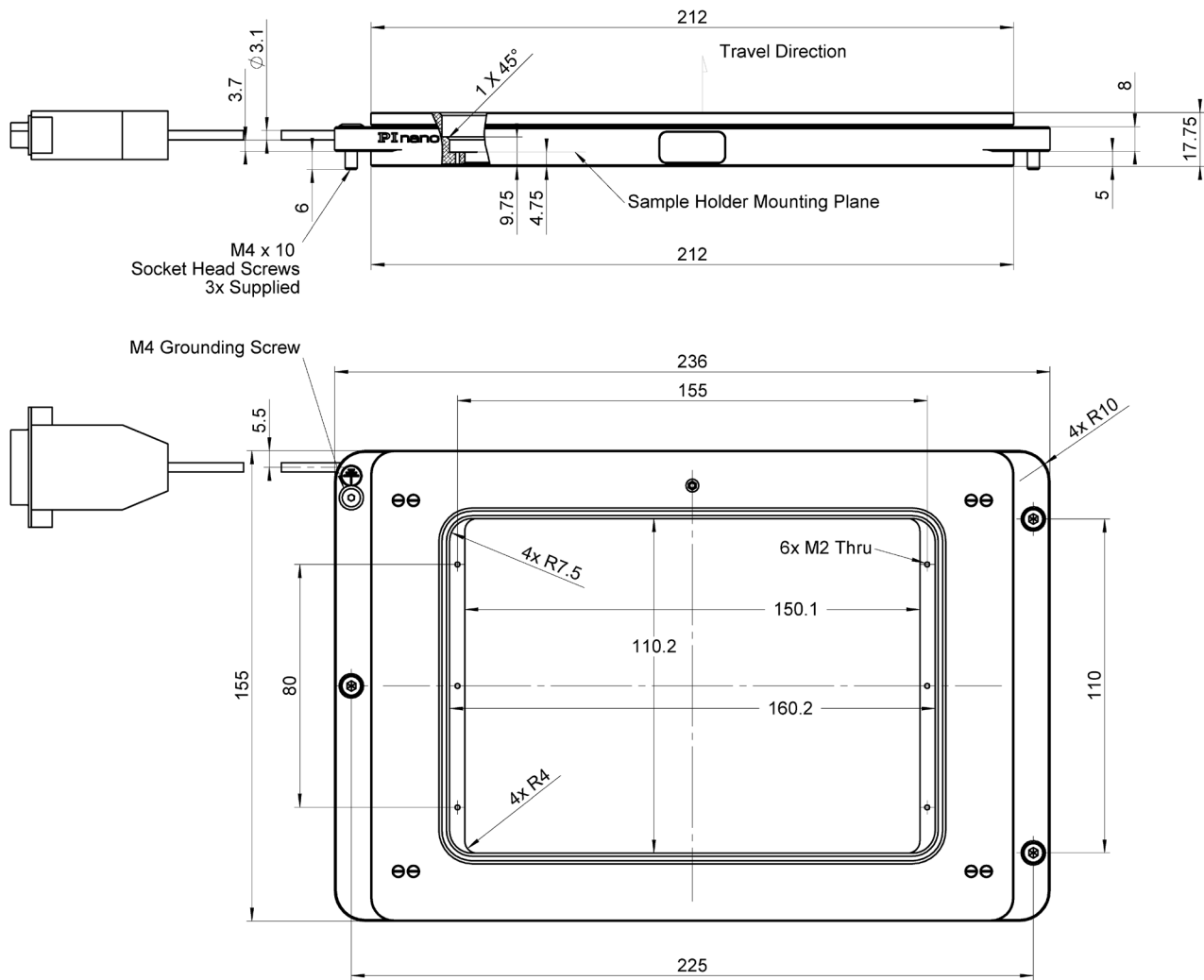
	PD73Z2ROW / P-736.ZRN2S	PD73Z2COW / P-736.ZCN2S	Unit	Tolerance
Active axes	Z	Z		
Motion and positioning				
Integrated sensor	Piezoresistive	Capacitive		
Closed-loop travel range	220	220	µm	
Closed-loop resolution	1	1	nm	typ.
Mechanical properties				
Resonant frequency, under load, at 100 g	250	250	Hz	
Recommended load*	500	500	g	max.
Drive properties				
Piezo ceramic	PICMA® P-885	PICMA® P-885		
Miscellaneous				
Operating temperature range	15 to 40	15 to 40	°C	
Material	Aluminum	Aluminum		
Mass	850	850	g	±5 %
Cable length	1.7	1.7	m	±10 mm
Piezo controller	E-709 digital servo (included in scope of delivery)			
Communication interfaces	USB, RS-232, SPI			
I/O connector	HD D-sub 26-pin 1× analog input 0 to 10 V 1× sensor monitor 0 to 10 V 1× digital input (LVTTTL, programmable) 1× analog output 5× digital outputs (LVTTTL, 3× predefined, 2× programmable)			
Command set	PI General Command Set (GCS)			
User software	PIMikroMove			
Software drivers	NI LabVIEW driver, dynamic libraries for Windows and Linux. Supported by MATLAB, µManager, Andor iQ			
Supported functions	Wave generator, data recorder, auto zero, trigger I/O			
Controller dimensions	160 mm × 96 mm × 33 mm			

* For dynamic operation. Higher dynamics are possible with a reduced load.

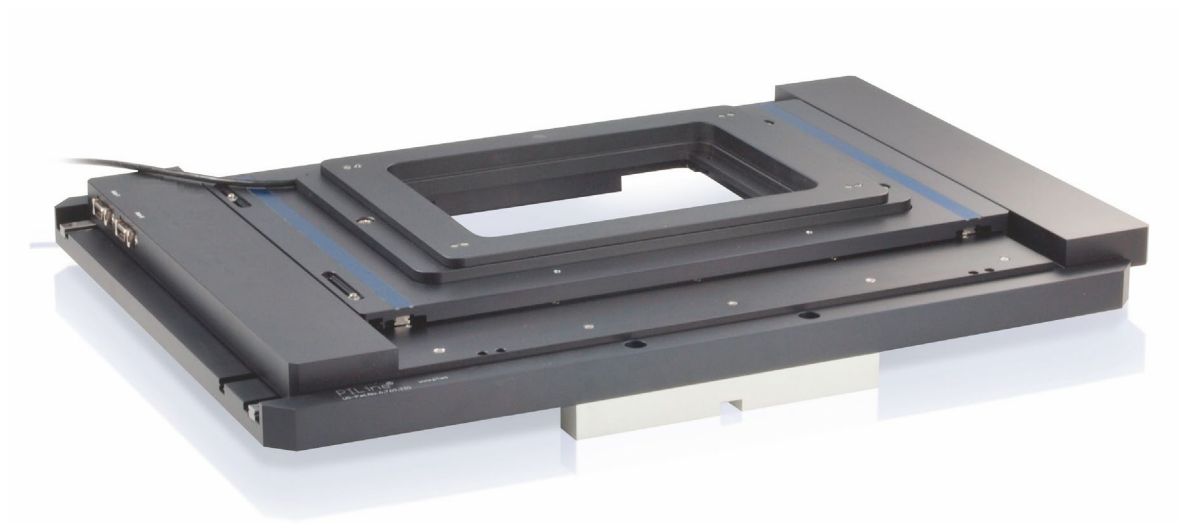
Drawings / Images



P-736.ZCO / P-736.ZRO, dimensions in mm. Note that a comma is used in the drawings instead of a decimal point.



P-736.ZCN2 / P-736.ZRN2, dimensions in mm. Note that a comma is used in the drawings instead of a decimal point.



P-736.ZCN2 in combination with the XY stage M-687 with extra large free aperture

Ordering Information

PD73Z2ROW

PI nano® Z piezo scanner system with clear aperture for microtiter plates, for inverted Olympus microscopes, 220 µm, piezoresistive sensors, with USB digital controller

PD73Z2COW

PI nano® Z piezo scanner system with clear aperture for microtiter plates, for inverted Olympus microscopes, 220 µm, capacitive sensor, with USB digital controller

PD73Z2RNW

PI nano® Z piezo scanner system with clear aperture for microtiter plates, for inverted Nikon microscopes, 220 µm, piezoresistive sensors, with USB digital controller

PD73Z2CNW

PI nano® Z piezo scanner system with clear aperture for microtiter plates, for inverted Nikon microscopes, 220 µm, capacitive sensors, with USB digital controller